

RESPONSE UNDER 37 CFR 1.116 EXPEDITED PROCEDURE **EXAMINING GROUP 2800**

PATENT APPLICATION Docket No. 5484-048 Client No. PX828-US/SSD

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Byung-Sup Shim and Young-Ho Kim

Serial No.

09/305,240

Examiner:

Nadav, Ori

Filed:

May 4, 1999

Art Unit:

2811

For:

OPEN DRAIN INPUT/OUTPUT STRUCTURE AND

MANUFACTURING METHOD THEREOF IN SEMICONDUCTOR

DEVICE

Confirmation No.

1838

MAIL STOP AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116

Responsive to the Final Office Action, Paper No. 30, dated October 7, 2003, please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop AF; Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Date: December 4, 2003

Adrienne Chocholak